

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	29762	pressure same semiconductor	USPAT	ADJ	ON	2005/09/01 13:20
L2	99554	(electrode or contact) with back	USPAT	ADJ	ON	2005/09/01 13:20
L3	238	L1 same L2	USPAT	ADJ	ON	2005/09/01 13:20
L4	46746	pressure (detecting or detector or sensor)	USPAT	ADJ	ON	2005/09/01 13:21
L5	200	L4 same L2	USPAT	ADJ	ON	2005/09/01 13:21
L6	896	((257/415) or (257/417-418)).CCLS.	USPAT	OR	OFF	2005/09/01 13:23
L7	67	L2 and L6	USPAT	ADJ	ON	2005/09/01 13:23
L8	78713	(electrode or contact) with back	US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2005/09/01 13:23
L9	87111	pressure (detecting or detector or sensor)	US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2005/09/01 13:23
L10	187	L8 same L9	US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	ADJ	ON	2005/09/01 13:24
L11	1113	transducer same L2	USPAT	ADJ	ON	2005/09/01 13:26
L12	197	L11 and semiconductor	USPAT	ADJ	ON	2005/09/01 13:26
L13	238	L1 same L2	USPAT	ADJ	ON	2005/09/01 13:29
L14	31	L13 and housing	USPAT	ADJ	ON	2005/09/01 13:29